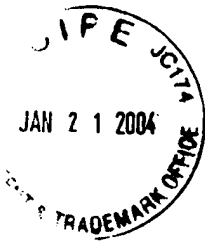


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1763
PATENT
Customer No. 22,852
Attorney Docket No. 08038.0048

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Nobuo ISHII) Group Art Unit: 1763
Serial No.: 09/776,675) Examiner: A. Crowell
Filed: February 6, 2001)
For: MICROWAVE PLASMA)
PROCESSING SYSTEM)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

REQUEST FOR RECONSIDERATION

In reply to the Office Action of October 2, 2003, the period for reply having been extended to February 2, 2004, by a Petition for a one-month extension of time and fee payment filed concurrently herewith, Applicant respectfully requests that the Examiner reconsider the present application and withdraw all of the claim rejections for the reasons explained below.

Claims 1-8 and 15-24 are pending in the application, with claims 1, 2, 15, and 21 being independent claims. No claim has been amended.

§ 103 Rejection Based on Matsumoto et al., Suzuki et al., and Dandl

Claims 1, 3, 5, 6, 8, 15-19, 21, and 23 were under 35 U.S.C. § 103(a) as being unpatentable over Matsumoto et al. (Japanese Patent Publication No. 11-121196) in view of Suzuki et al. (European Patent Application Publication No. 0880164) and Dandl